

TOSHIBA



Micro Manipulator Array for Nano-bioelectronics Era

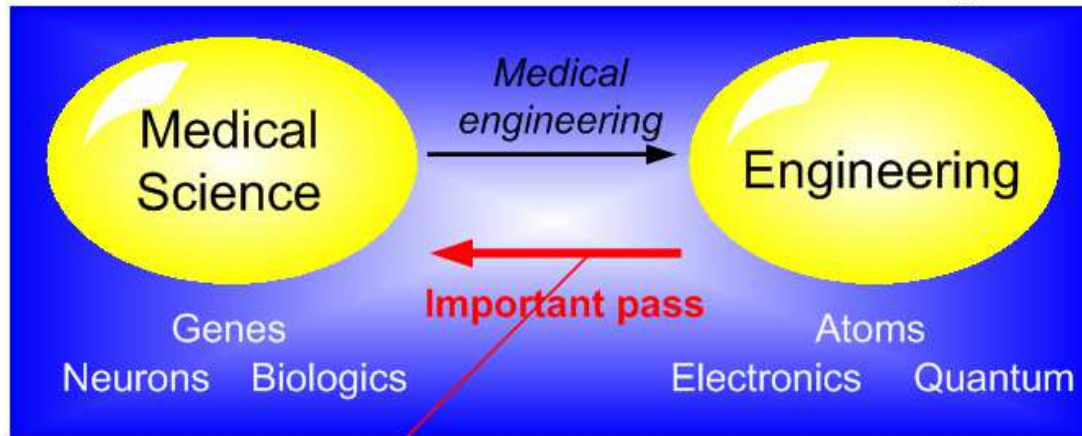
K. Suzuki, Y. Naruse, H. Funaki, K. Itaya and S. Uchikoga
Advanced Electron Devices Laboratory
Corporate Research and Development Center
TOSHIBA Corporation

OUTLINE

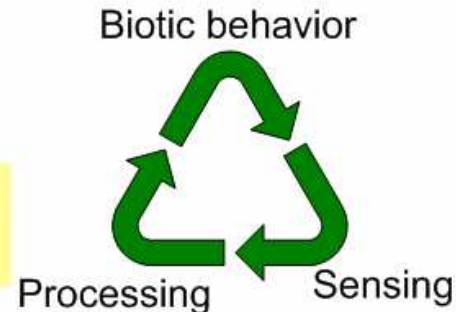
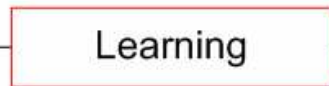
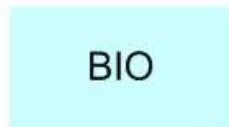
- **Introduction**
- **Device Structure**
- **Physical Interaction**
- **Experiments & Results**
- **Future Visions**
- **Summary**

MOTIVATION

Fusion between medical science & engineering



*Bio computing Neuro computing
Self repair*

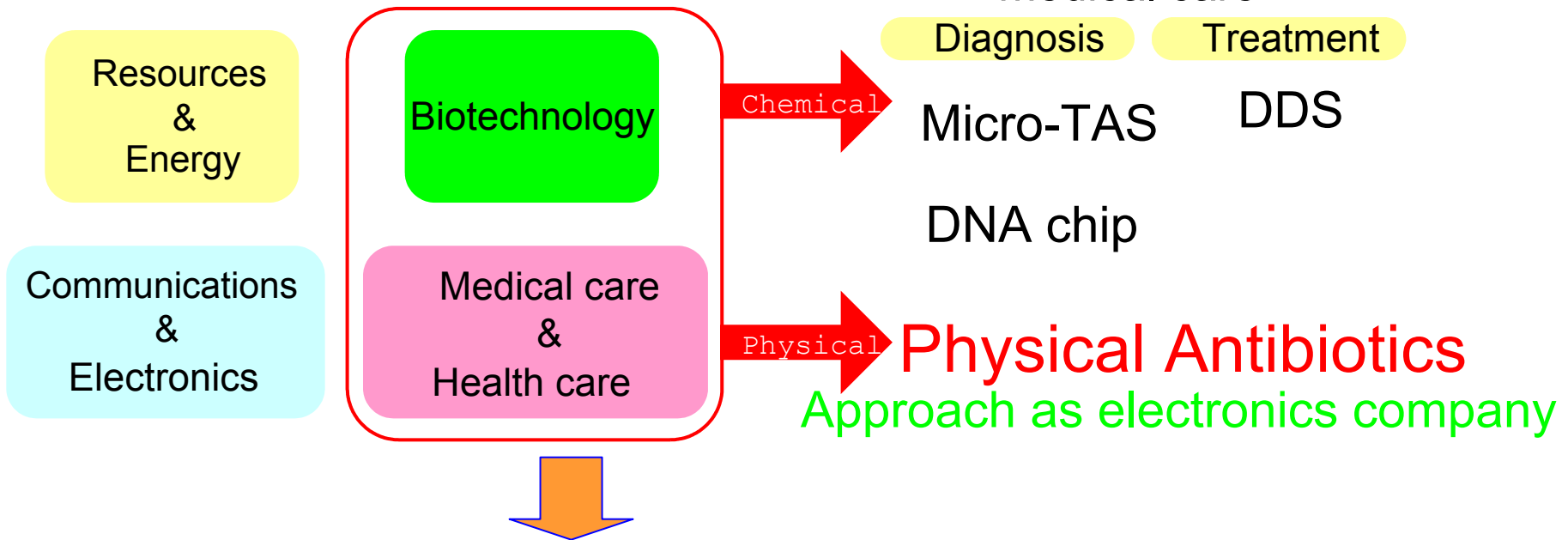


Self-Repair and Supplemental Functionality - The ability for biological organs and organisms to function even though some cells have been damaged.

THE APPROACH

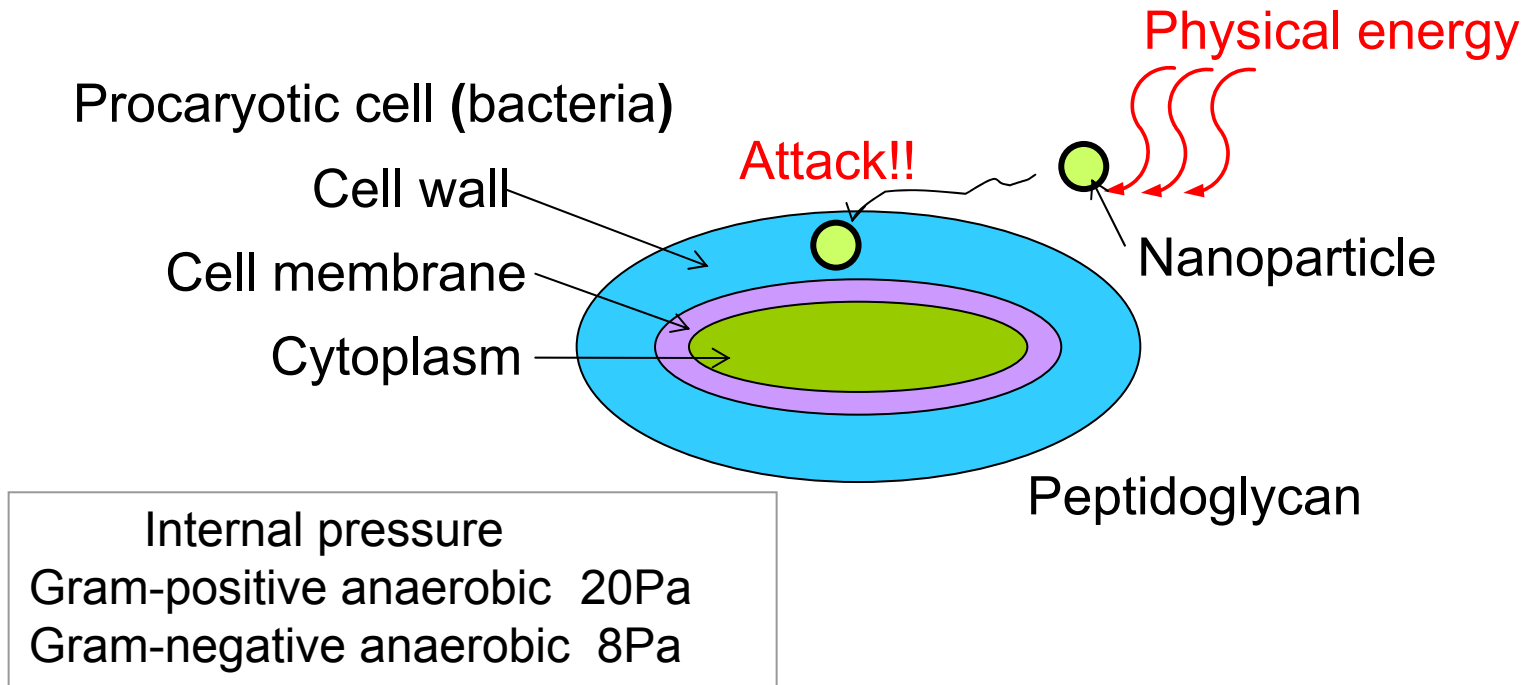
Applied field of nanotechnology

Application for next generation medical care



This leads to the promising future technology of "tailor-made medical treatments" corresponding to the needs of the individual.

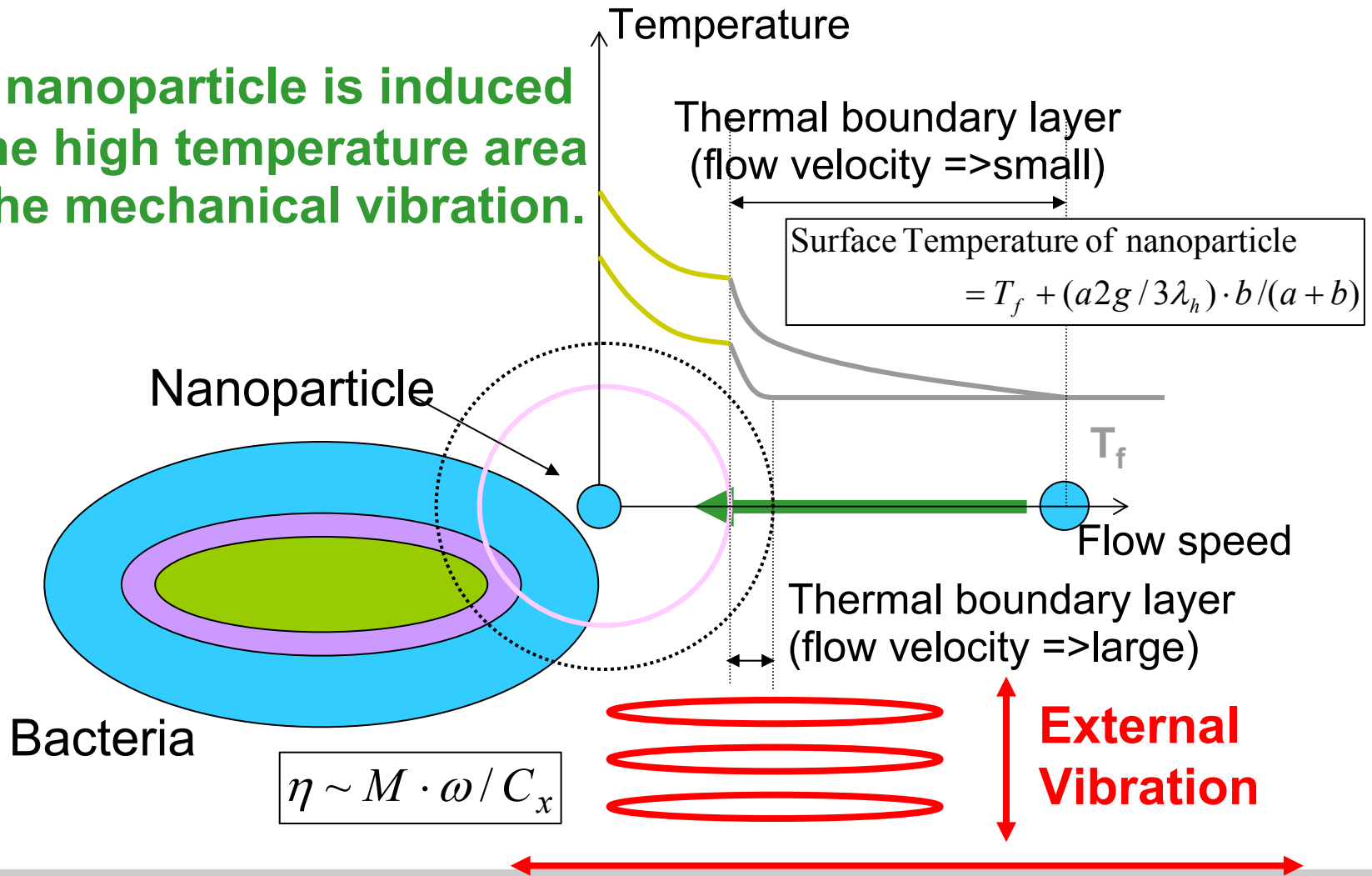
PHYSICAL ANTIBIOTICS



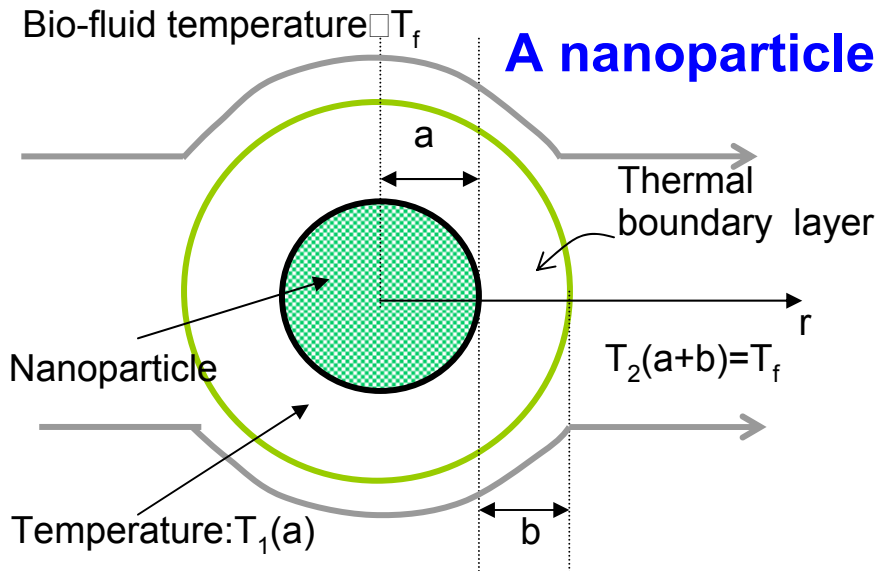
Mechanical vibration where a high surface temperature is obtained by the thermal boundary theory is one method by which nanoparticles can be introduced.

ADSORPTION OF NANOPARTICLES

The nanoparticle is induced to the high temperature area by the mechanical vibration.



ADSORPTION OF NANOPARTICLES



A nanoparticle in spherical coordinates

$$T_1(r) = A/r + B, \quad 0 < r < a \quad (1)$$

$$T_2(r) = C/r + D, \quad a < r < a+b \quad (2)$$

$$-\lambda_a (dT_1/dr)_{r=a} \cdot 4\pi a^2 = 4\pi a^3 \cdot g/3 \quad (3)$$

$$-\lambda_h (dT_2/dr)_{r=a} \cdot 4\pi a^2 = 4\pi a^3 \cdot g/3 \quad (4)$$

$$T_2(a+b) = T_f \quad (5)$$

$$T_1(a) = T_2(a) \quad (6)$$

$$T_1(a) = T_f + (a^2 g/3\lambda_h) \cdot b/(a+b) \quad (7)$$

Parameters

$T_1(r)$: Thermal distribution (nanoparticles)

a : Radius of the nanoparticles

λ_a : Thermal conductivity (nanoparticles)

g : Energy generation rate in the nanoparticles

T_f : Flow temperature of the biofluid

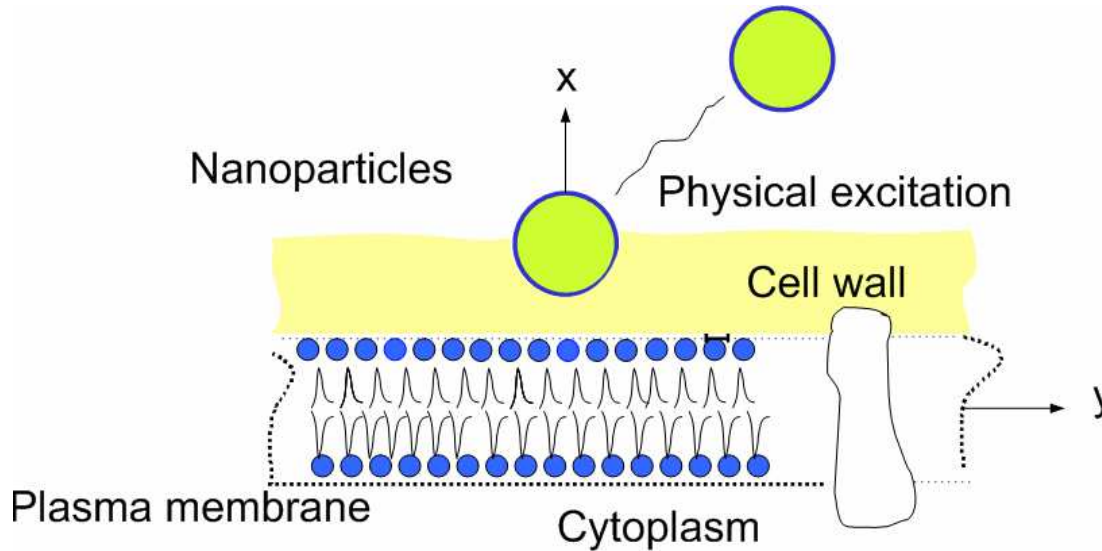
$T_1(a)$: Surface temperature of the nanoparticles

$T_2(r)$: Thermal distribution (stagnant layer)

b : Width of the stagnant layer

λ_b : Thermal conductivity (biofluid)

VIBRATION EFFICIENCY



Parameters

M: Motion for a mobile protein with mass
 C_x : Viscous damping constant
 ω : Angular frequency of external mechanical vibration
 η : Vibration efficiency as the ratio of the absolute value
D: Diffusion constant
 k_B : Boltzmann constant
T: Absolute temperature

$$M \cdot x'' = -C_x(x' - y') \quad (1)$$

$$M \cdot \Delta x'' + C_x \cdot \Delta x' = -M \cdot y'' \quad (2)$$

$$\Delta x = A \cdot e^{j\omega t} \quad (3)$$

$$y = B \cdot e^{j\omega t} \quad (4)$$

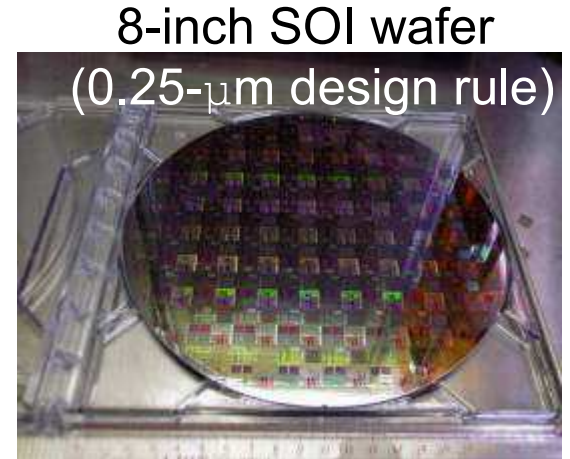
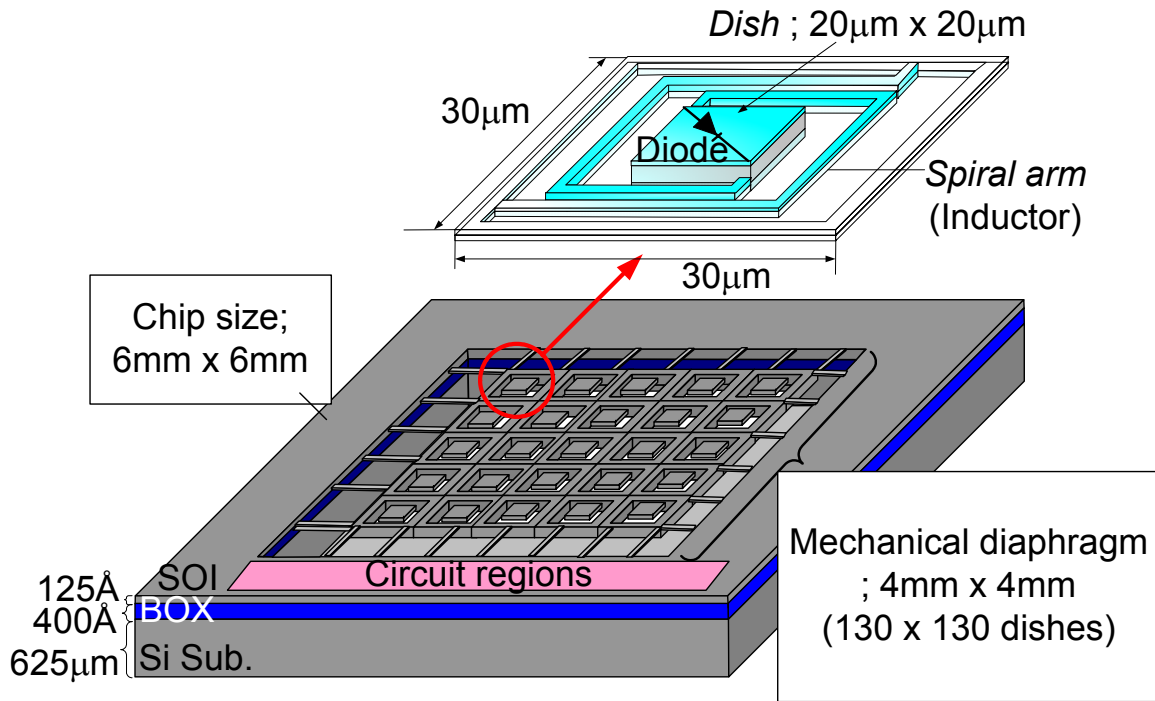
$$(C_x / M \cdot \omega)^2 = \eta^{-2} - 1 \quad (5)$$

$$C_x = k_B T / D \quad (6)$$

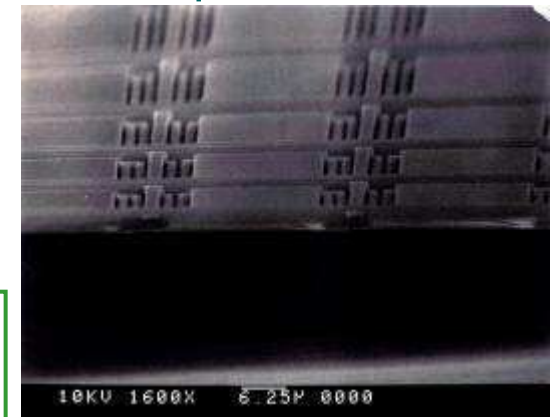
$$\eta \sim M \cdot \omega / C_x \quad (7)$$

Indicator for designing the in vivo and In vitro applications.

DEVICE STRUCTURE



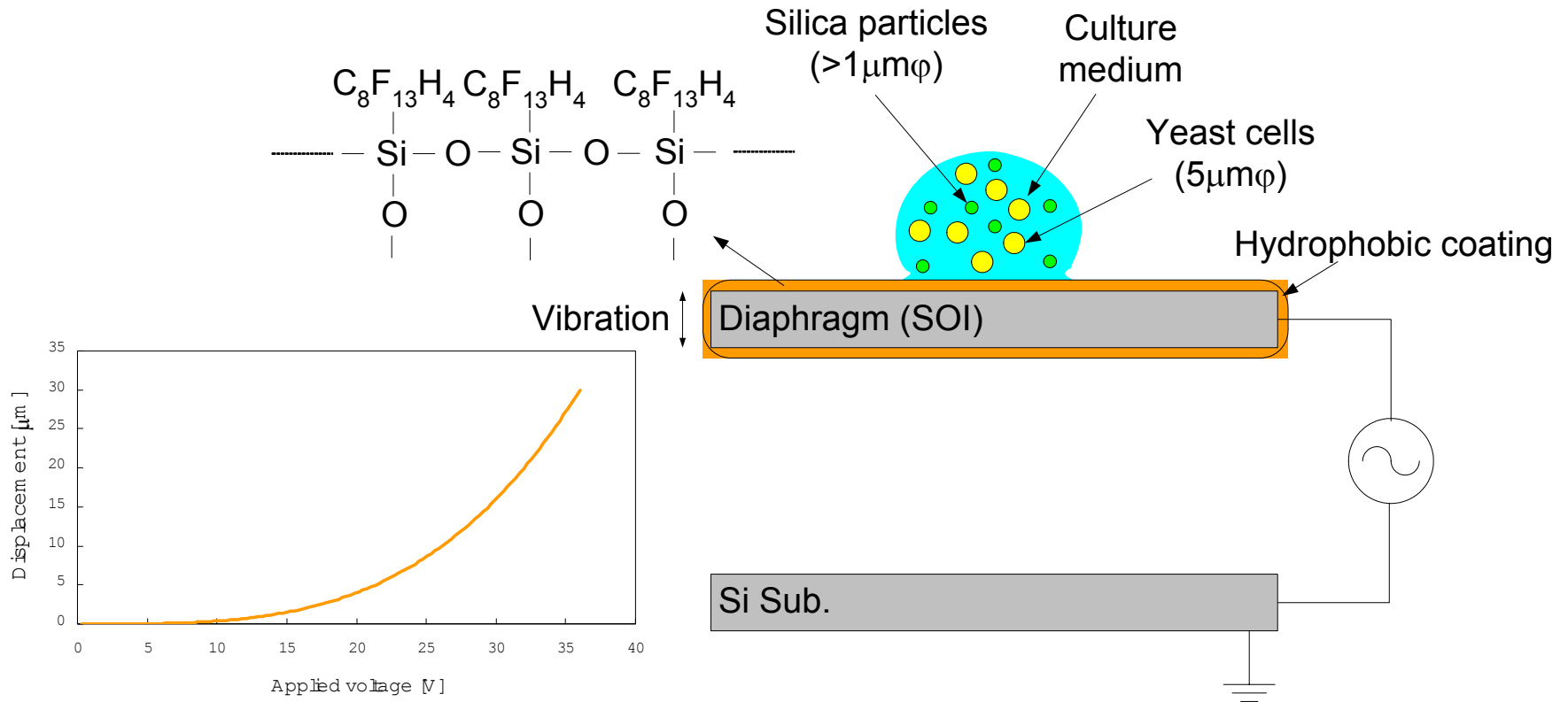
CMOS+MEMS process



Mechanical diaphragm (SEM image)

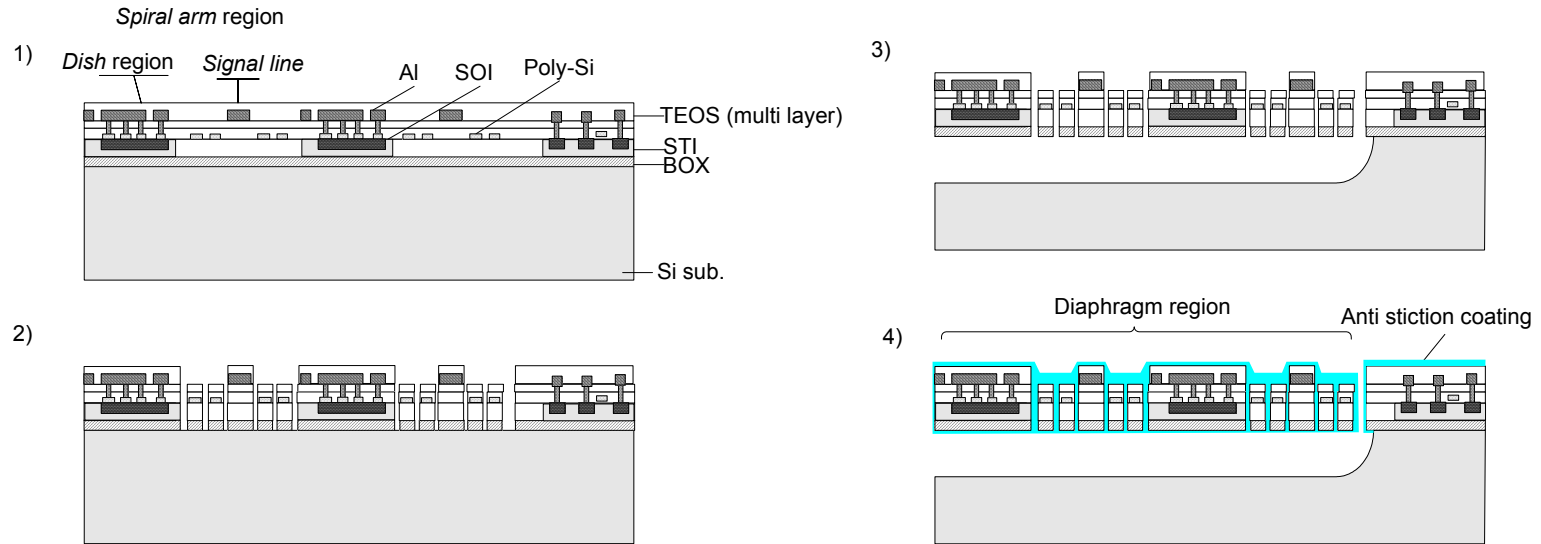
- Collision energy => Vibrating
- Electric heating energy => Joule heating

ELECTROSTATIC VIBRATING



Yeast cells are chosen for testing material since they have similar characteristics to typical bio-cells.

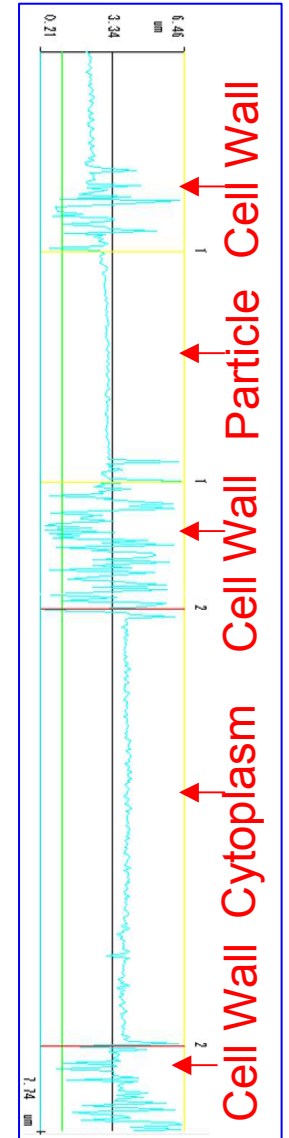
FABRICATION PROCESS



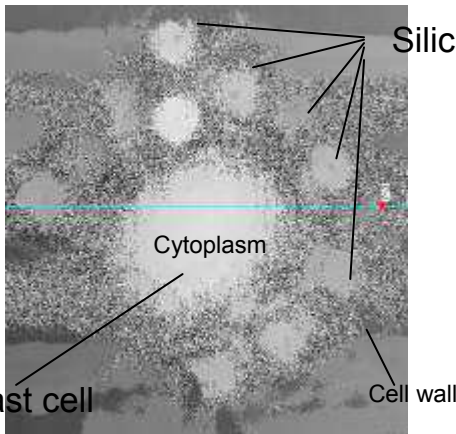
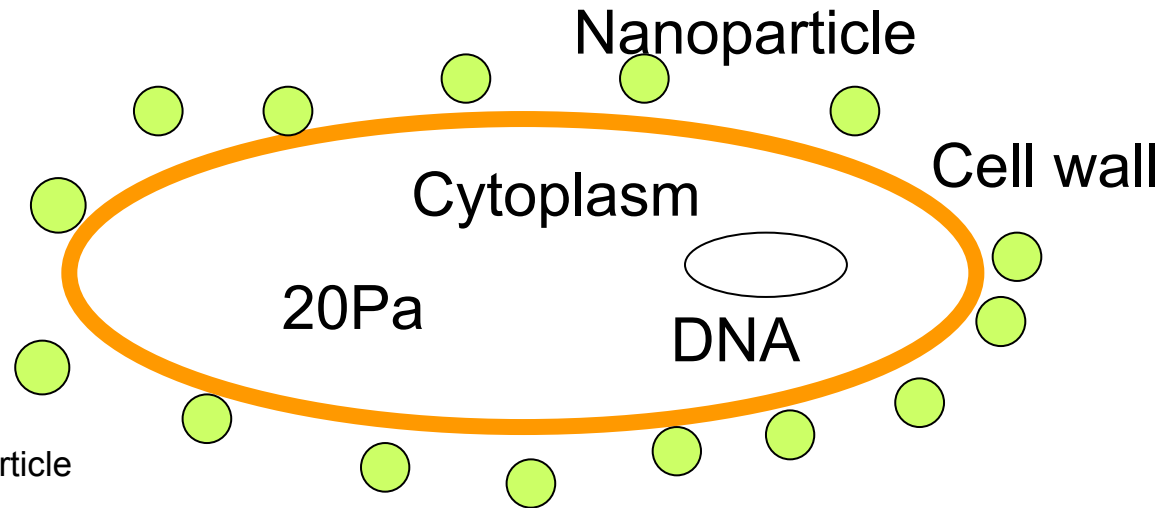
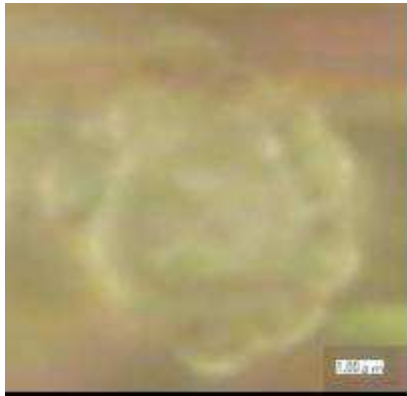
- (1) The *micro dish* and *spiral arms* are fabricated by CMOS processing (0.25- μm design rule).
- (2) The TEOS layer is etched down to the silicon substrate by RIE, and the formed lattice is neatly arranged in a 30- μm pitch.
- (3) A cavity is formed by isotropically etching the silicon substrate using XeF_2 gas.
- (4) A hydrophobic coating is deposited using $\text{C}_8\text{F}_{13}\text{H}_4\text{SiCl}_3$ and H_2O gases.

INTERACTION BETWEEN CELLS & PARTICLES

	Yeast cell & Silica particle	After excitation (30V 1kHz signal)
Optical microscope		
Laser microscope		



HEATING OF HIGH-PRESSURE CYTOPLASM USING GROUPS OF NANOPARTICLES

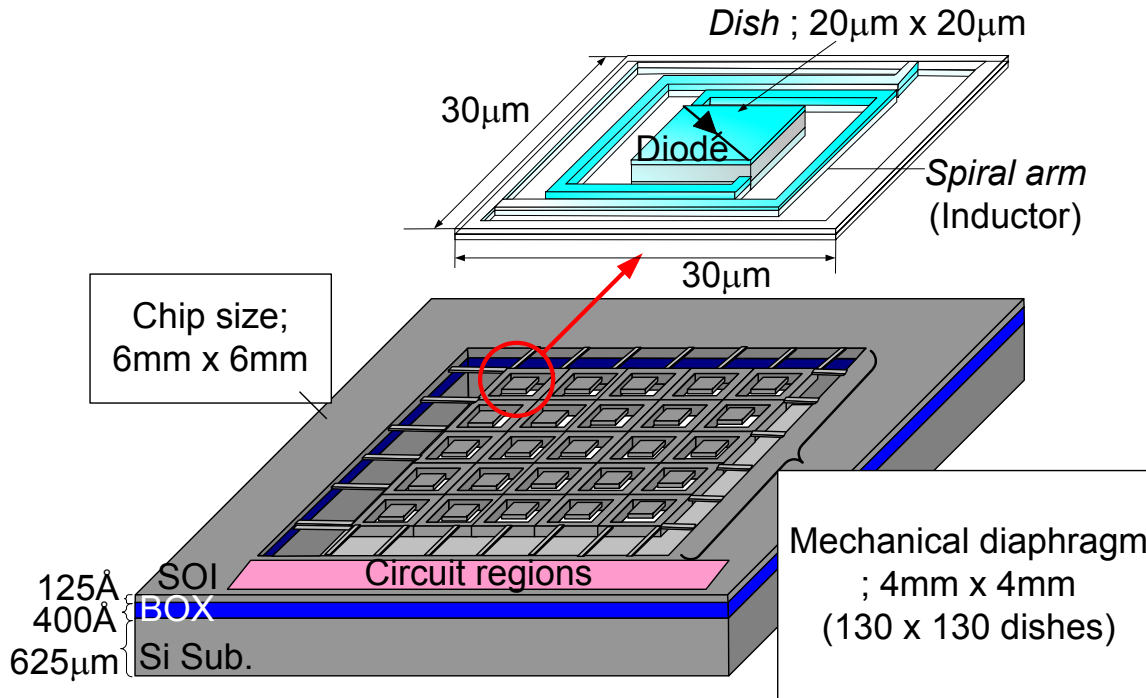


Molar elevation of boiling point

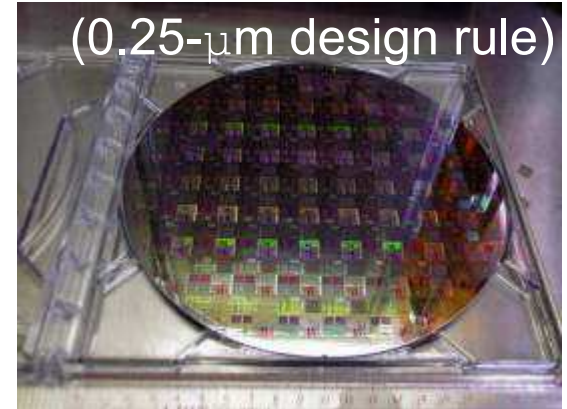
: sterilization temperature 150~200°C

Osmotic pressure : $P=k*C*T$ [mol/l] [k]
(W.Pfeffer)

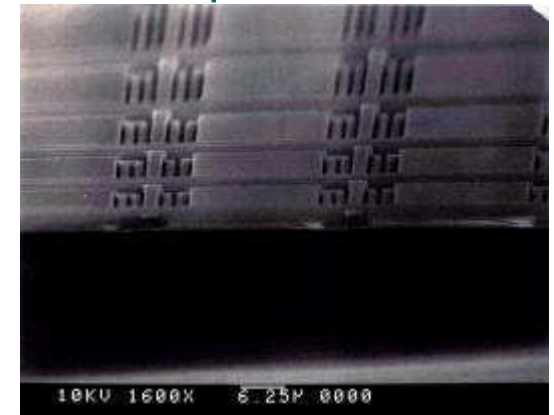
DEVICE STRUCTURE



8-inch SOI wafer (0.25- μ m design rule)



CMOS+MEMS process



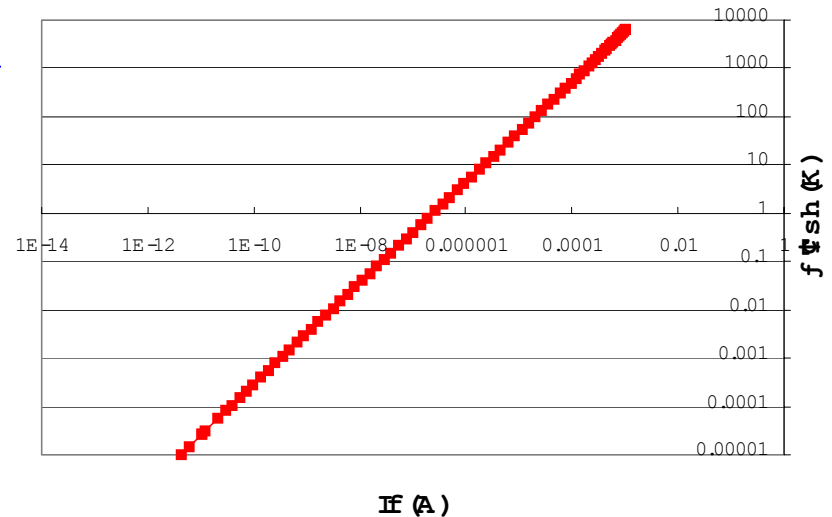
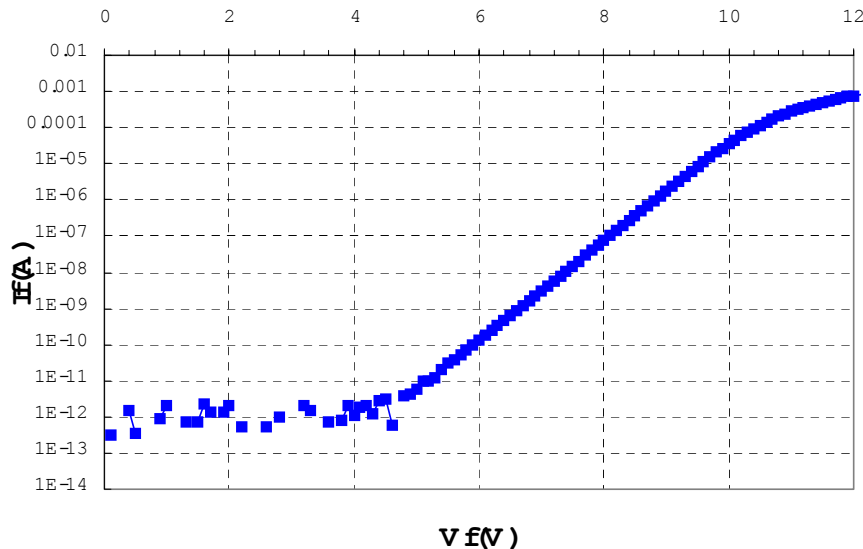
Mechanical diaphragm (SEM image)

- Collision energy => Vibrating
- **Electric heating energy => Joule heating**

LOCAL HEATING AT MICRO DISH

I-V characteristic versus dish temperature
(In atmosphere)

Temperature increase of the micro dish versus If

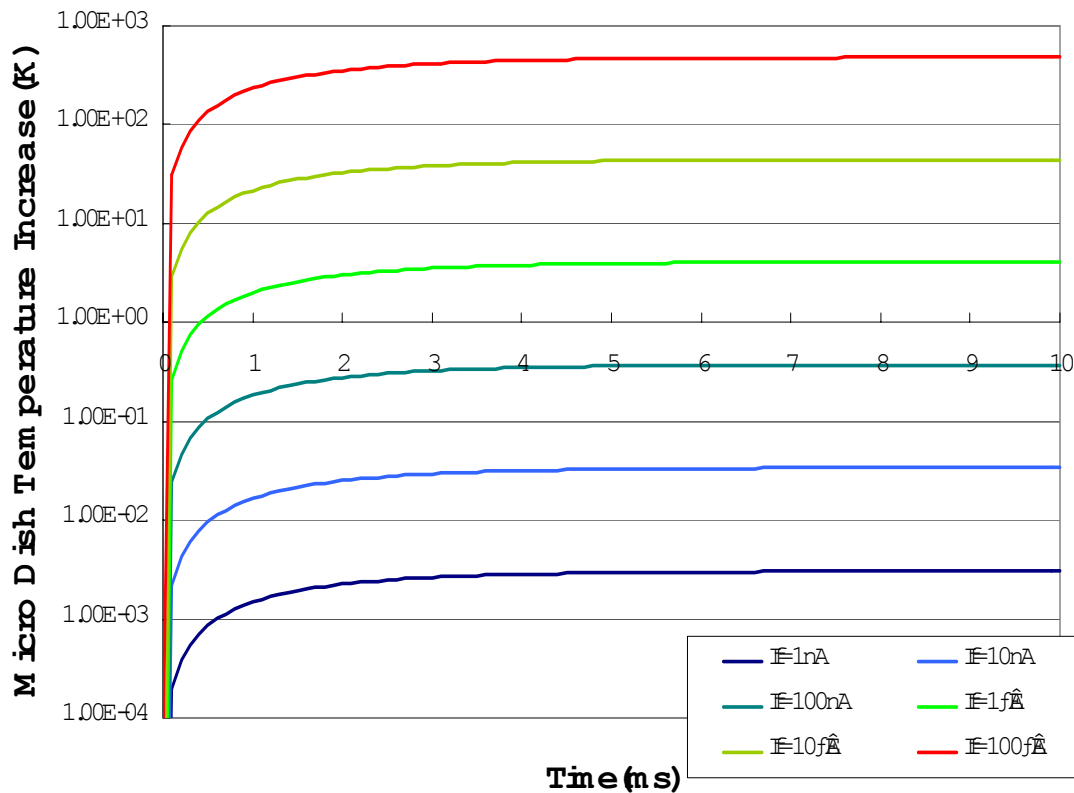


$$G_{th} : 2.0E-6 \text{ (W/K)}$$

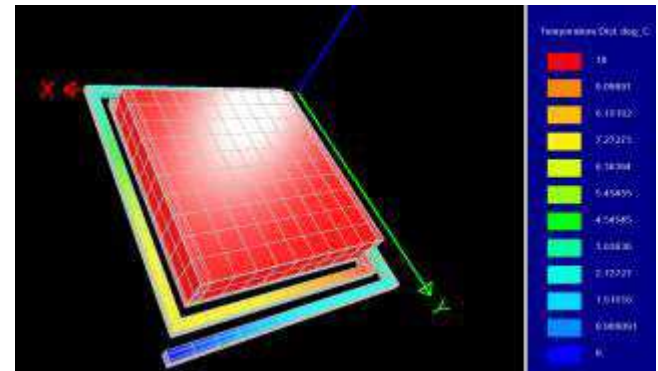
$$C_{th} : 3.0E-9 \text{ (J/K)}$$

$$\Delta T = \frac{Vf \cdot If}{G_{th}} \{1 - \exp(-tG_{th} \cdot C_{th})\}$$

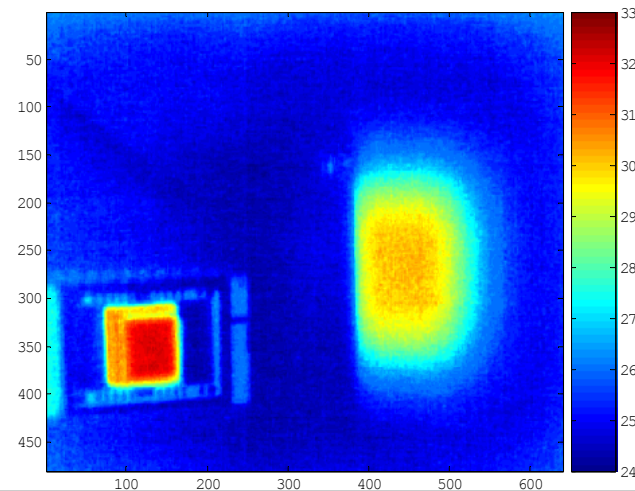
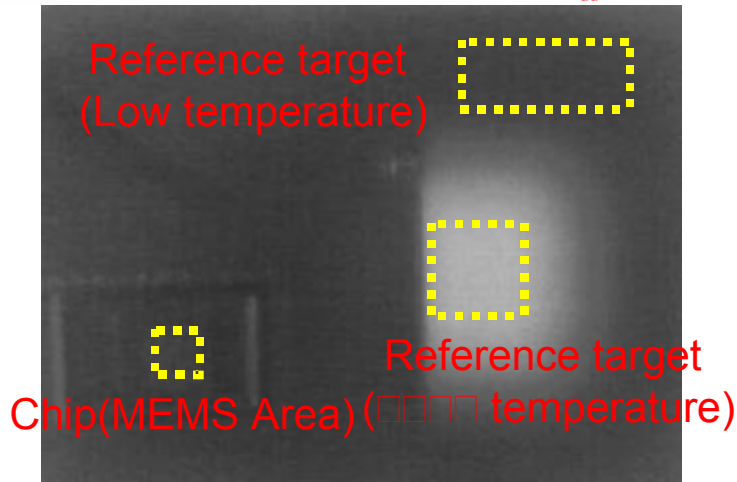
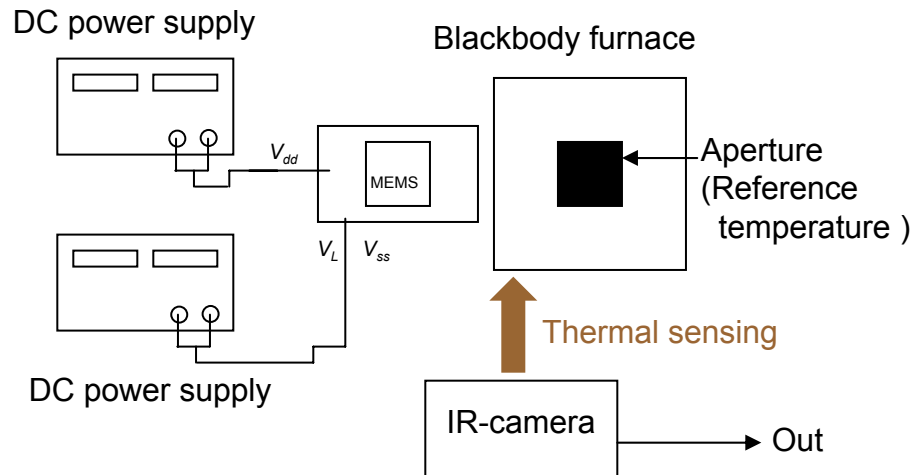
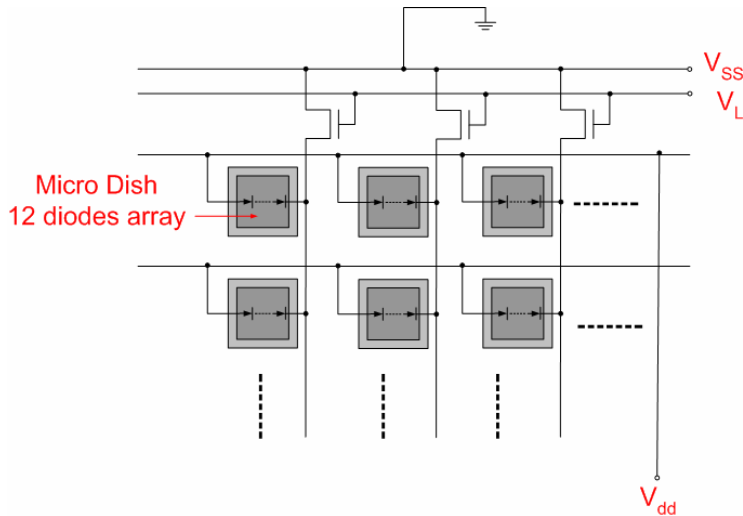
TURN ON CHARACTERISTICS



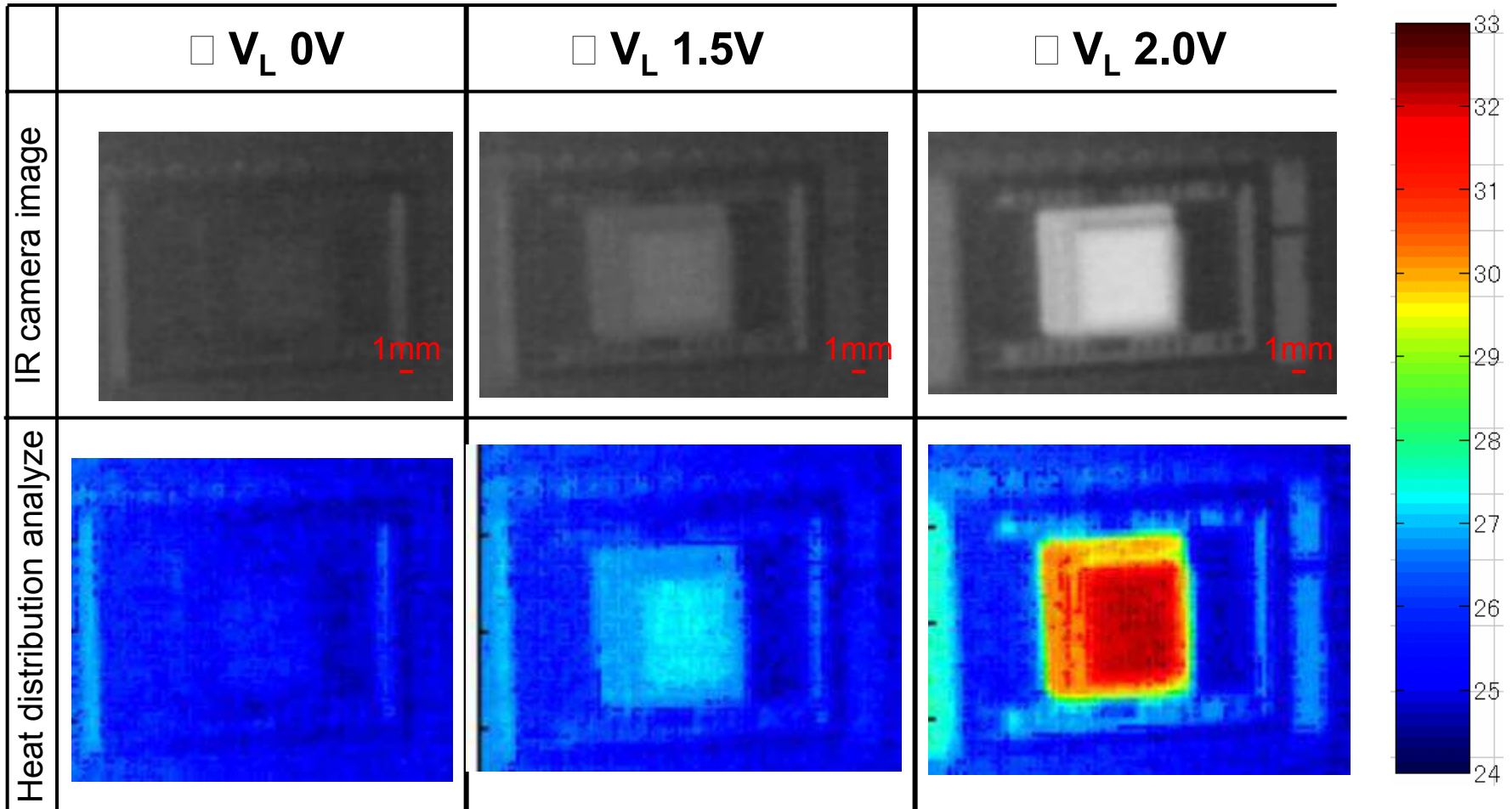
Thermic effect of micro dish (10°C) by FEM



HEATING EXPERIMENT I.



HEATING EXPERIMENT RESULTS I.

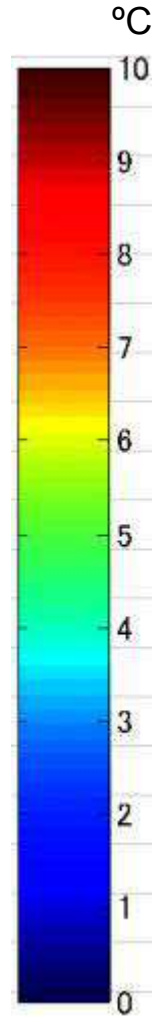
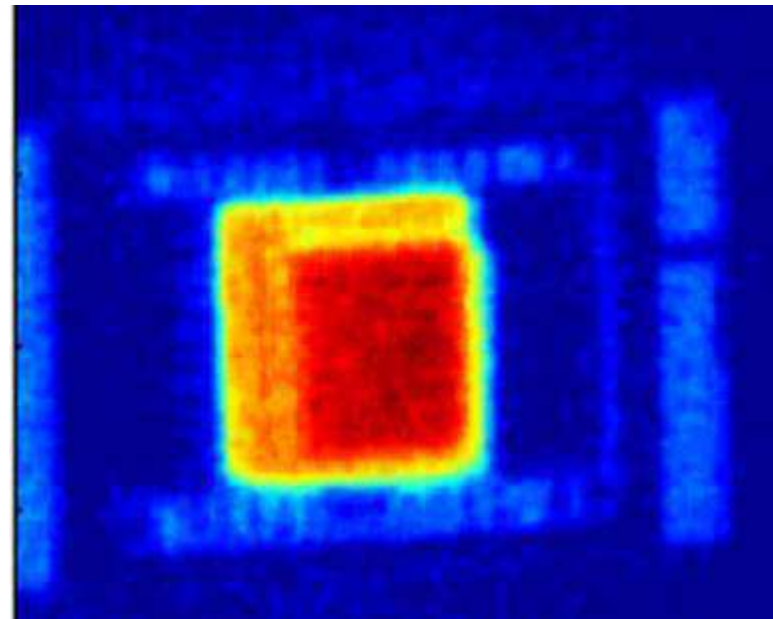
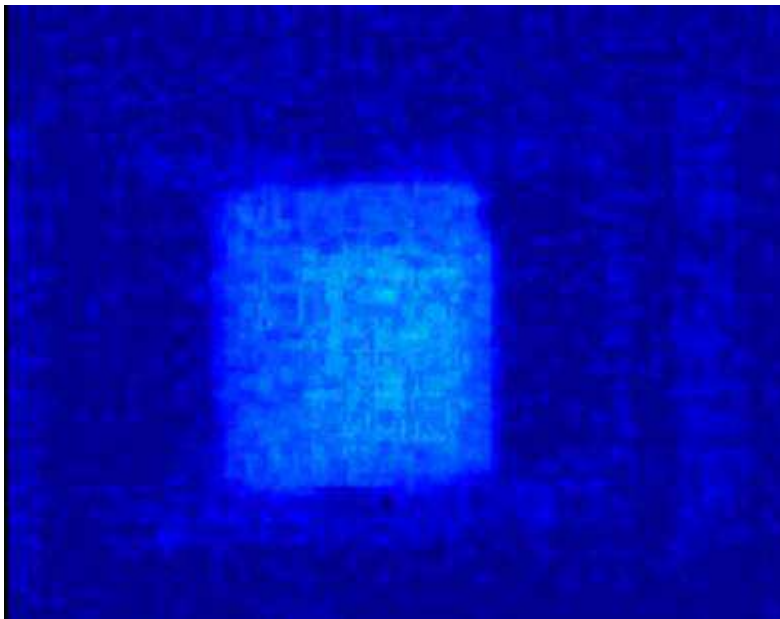


HEATING EXPERIMENT RESULTS I.

-Thermal difference-

□ - □

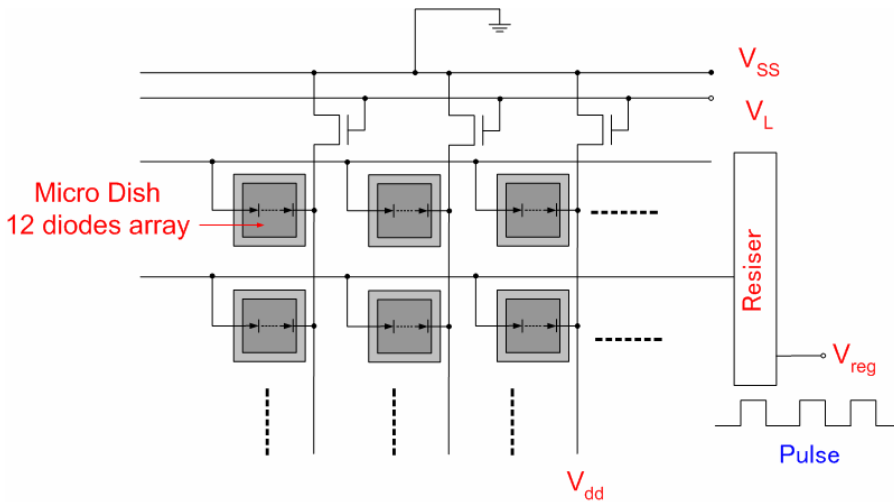
□ - □



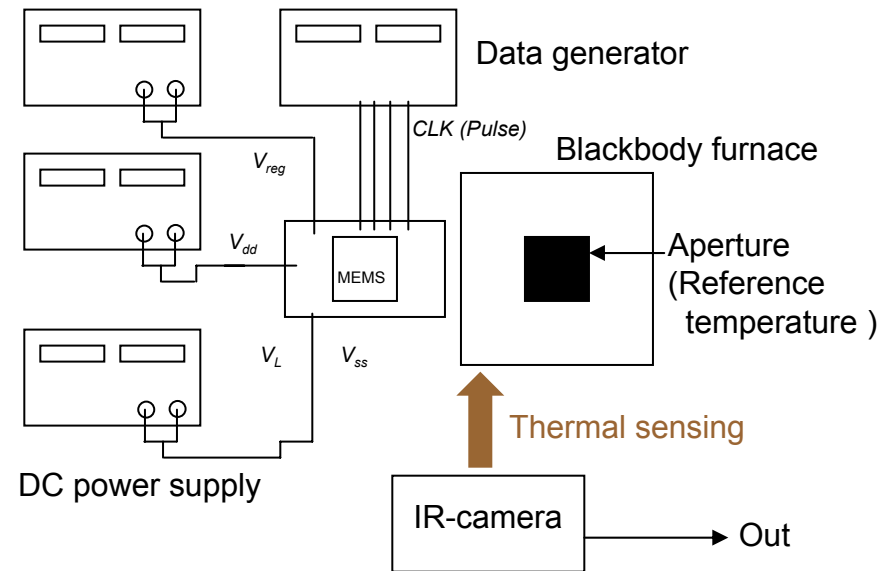
Heat effect : approx. 9.7 °C

HEATING EXPERIMENT II.

Circuit configuration

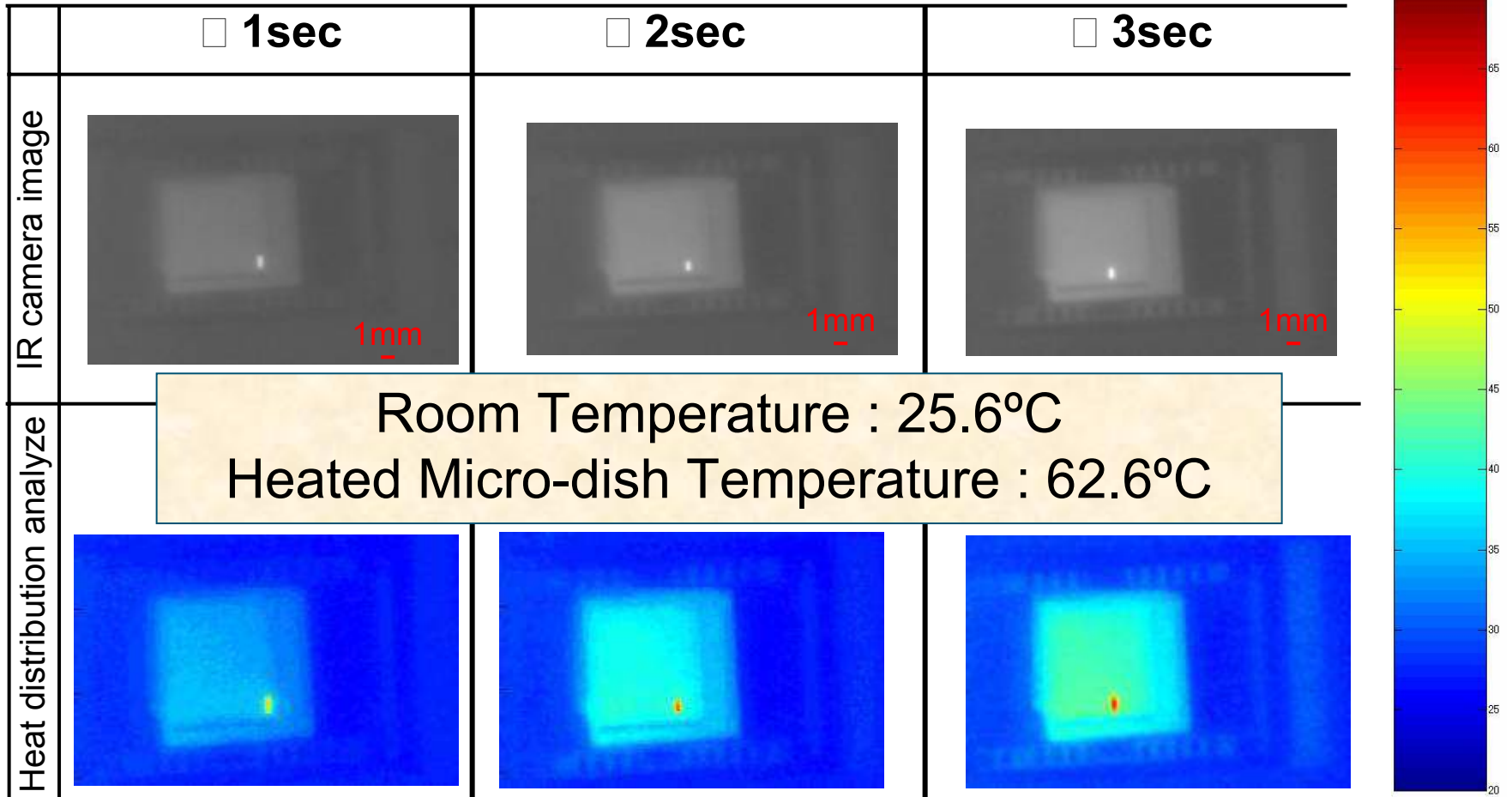


Measurement configuration



HEATING EXPERIMENT RESULTS II.

1 Pulse width : 100ms

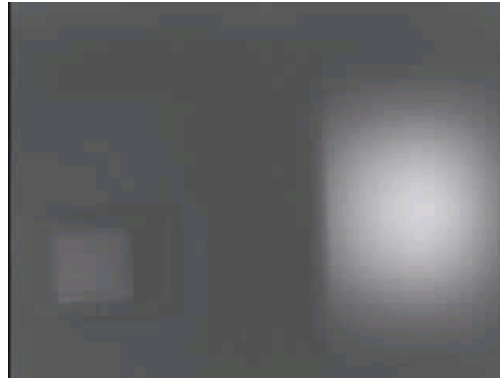


HEATING EXPERIMENT RESULTS II.

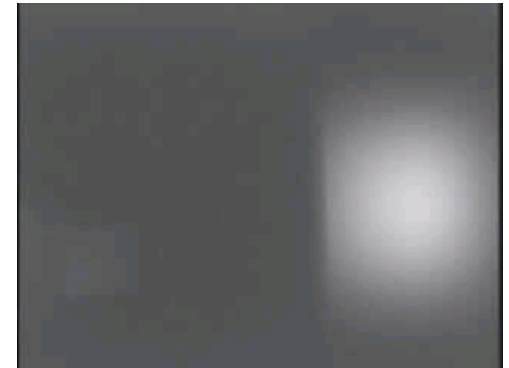
-Video movies-



Pulse: 1s



Pulse: 100ms



Pulse: 50ms



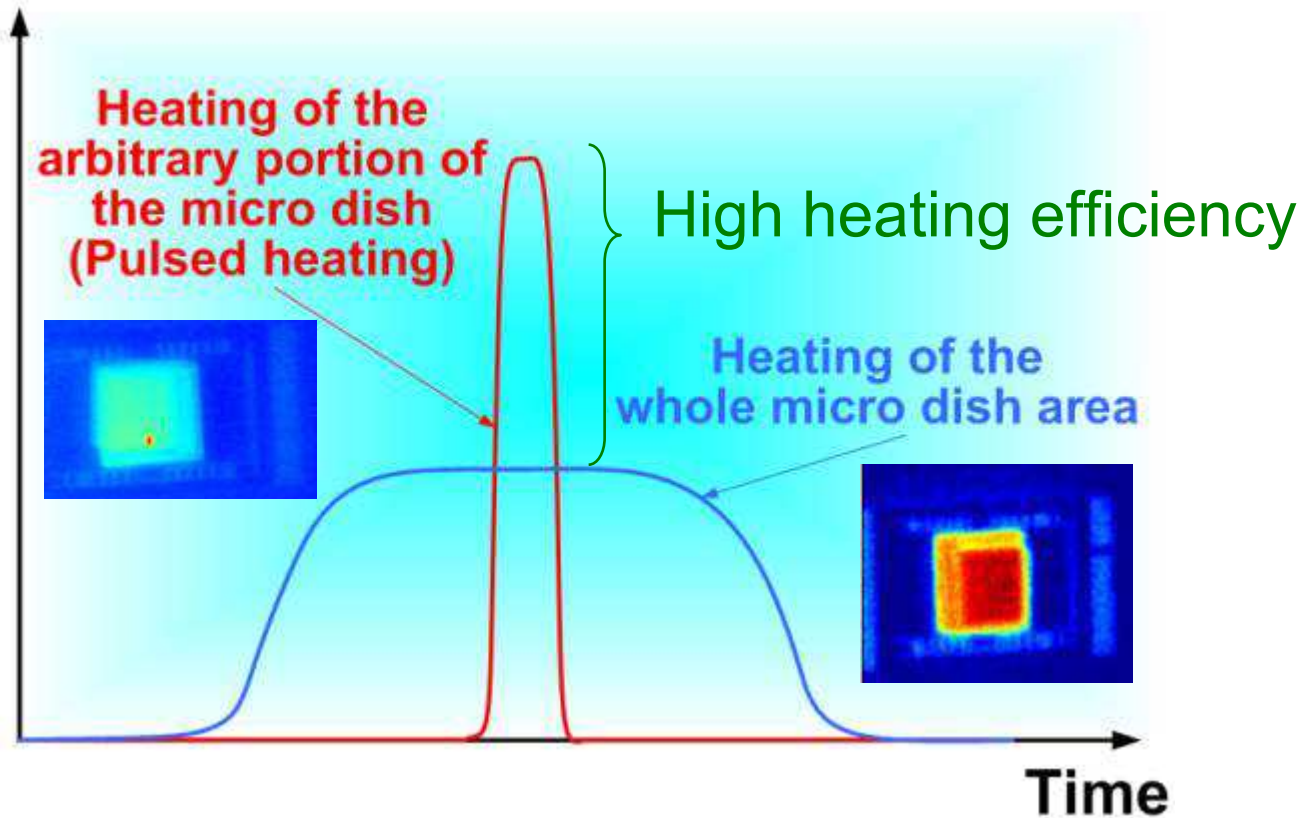
Pulse: 10ms



Pulse: 1ms

HEATING EFFECT COMPARISON

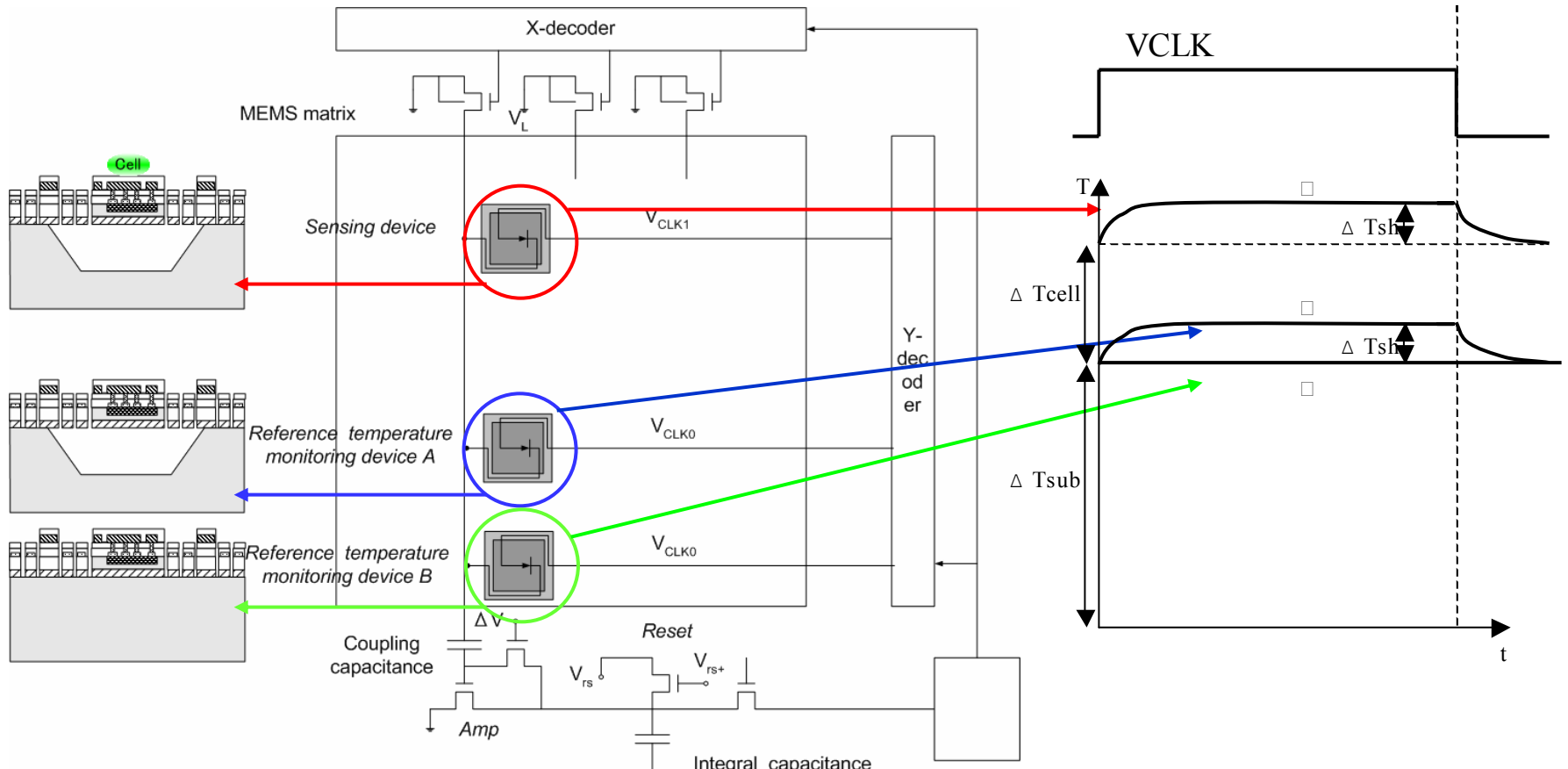
Temperature



REMARKS (JOULE HEATING)

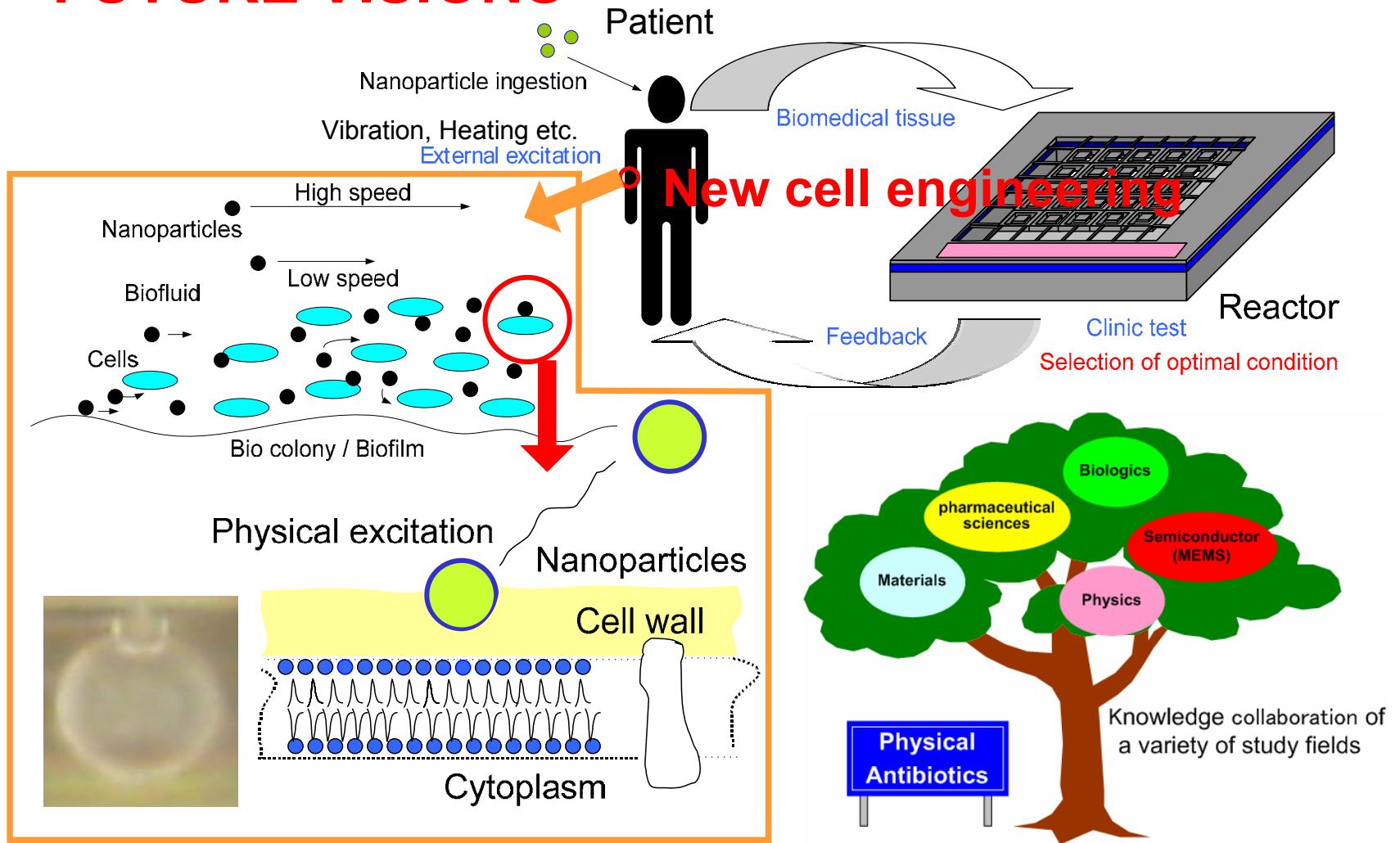
- ✓ **Heating of the whole micro dish array and just an arbitrary portion of the micro dish was demonstrated.**
- ✓ **Rapid temperature switching on ‘micro second’ order was confirmed.**
- ✓ **More than twice the heat effect was achieved in heating an arbitrary portion compared with heating the whole micro dish.**
(based on efficiency)

ADVANCED DEVICE



Exothermic biological reactions will cause temperature spikes in the vicinity of the reaction which in term causes the nearest diode to read a higher temperature. Scanning the array of temperature sensors across the chip will identify the particle X-Y position of the reaction.

FUTURE VISIONS



SUMMARY

- **We have developed a micro manipulator array using a novel MEMS-based structure.**
- **We also demonstrated direct physical control of the interaction between yeast cells and silica particles in liquid for the first time.**
- **The adsorption of the particle to the cell was demonstrated using vibrational energy, and Joule heating energy according to external excitation. These results show a potential impact in medical fields such as physical antibiotics and cell treatments and next generation bio-electronics schemes.**